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				Application Number	09/933,151
				Filing Date	August 21, 2001
				First Named Inventor	Koichiro Kishima
				Art Unit	2873
				Examiner Name	E. A. Lester
Sheet	1	of	1	Attorney Docket Number	Son-2198

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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	CA	"Usefulness of Magnetic Neutral Loop Discharge Plasma in Plasma Processing" Tsuboi, et al., Jpn. J. Appl. Phys. Vol. 34 (1995), pp. 2476-2481			
	CB	"Review of Inductively Coupled Plasmas for Plasma Processing", J. Hopwood, Plasma Sources Sci. Technol. 1, 1992, pp. 109-116.			
	CC	"High Rate and Highly Selective SiO ₂ Etching Employing Inductively Coupled Plasma", Fukasawa, et al., Jpn. J. Appl. Phys. Vol. 33, 1994, pp. 2139-2144			
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